



ASPEN/ASPE Spring 2017 Topical Meeting

Manufacture and Metrology of Structured and Freeform Surfaces for Functional Applications

15-17 March 2017, The Hong Kong Polytechnic University



Call for papers

Conference Committee

Meeting Chairmen:

- Prof. W.B. Lee, The Hong Kong Polytechnic University
- Dr. Jeffrey W. Roblee, AMETEK – Precitech Inc.

Secretary:

- Prof. Benny Cheung, The Hong Kong Polytechnic University

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- Prof. Christopher J. Evans, University of North Carolina - Charlotte
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- Prof. Kuang-Chao Fan, National Taiwan University
- Prof. Fengzhou Fang, Tianjin University
- Prof. Ruxu Du, The Chinese University of Hong Kong
- Dr. Sandy To, The Hong Kong Polytechnic University

Important Dates:

- Deadline for short abstract: 15 September, 2016
- Notification of the results: 1 November, 2016
- Deadline for submission of extended abstract: 16 January, 2017

The joint ASPEN(Asian Society for Precision Engineering and Nanotechnology)/ASPE (American Society for Precision Engineering) Spring Topical Meeting on the Manufacture and Metrology of Structured and Freeform Surfaces for Functional Applications is designed to focus industry, academic and governmental interest, and expertise on the advancement of technologies essential to the manufacture of structured and freeform surfaces.

Structured and freeform surfaces with functional characteristics have been widely used in many fields of industrial applications such as advanced optics, large-scale optics, aerospace, automotive, telecommunications, biomedical, micro-fluidics, etc. The meeting aims to provide an excellent opportunity and platform for academics and industries to discuss topics on the physical, mechanical, electronic, and chemical aspects in the design, fabrication and measurement of structured and freeform surfaces and their functional characteristics.

Guidelines for submitting Short Abstracts:

The abstract header should include a title, author(s) and the affiliation(s) of author(s) and keywords (up to six). The limit is **500 words**. Abstracts should be submitted electronically in PDF format and in A4 page size. At minimum, the font size should be 11.

The author(s) should indicate their preference for oral or poster presentation.

For more details, please refer to: www.aspen-aspe2017-topical.com



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